

(19)

Europäisches Patentamt

European Patent Office

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(11)

EP 1 072 967 A3

(12)

EUROPEAN PATENT APPLICATION

(88) Date of publication A3:
21.11.2001 Bulletin 2001/47

(51) Int Cl.7: G05B 19/418, G05B 17/02

(43) Date of publication A2:
31.01.2001 Bulletin 2001/05

(21) Application number: 00115577.9

(22) Date of filing: 19.07.2000

(84) Designated Contracting States:
AT BE CH CY DE DK ES FI FR GB GR IE IT LI LU
MC NL PT SE

Designated Extension States:
AL LT LV MK RO SI

(30) Priority: 29.07.1999 US 363966

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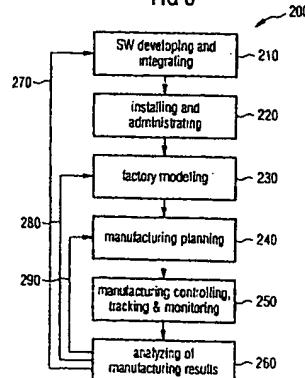
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(54) Computer integrated manufacturing techniques

(57) The present invention provides a novel distributed factory system framework including a novel factory automation lifecycle (200) having lifecycle activities for SW developing and integrating (210), installing and administrating (220), factory modeling (230), manufacturing planning (240), manufacturing controlling, monitoring and tracking (250) and analyzing of manufacturing results (260). The factory lifecycle comprises framework components. The distributed factory system framework also includes application components and SW building blocks. The framework components are adapted for managing the application components, while the application components are utilized to provide instructions for managing a process such as a wafer fab. The building blocks are adapted for forming or modifying framework and application components. The distributed factory system framework provides computer implemented

methods for integrating processing systems and facilitates process and equipment changes.

FIG 6





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EUROPEAN SEARCH REPORT

Application Number

EP 00 11 5577

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G05B			
The present search report has been drawn up for all claims			
Place of search	Date of completion of the search	Examiner	
MUNICH	27 September 2001	Helot, H	
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26. Nov. 2001

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